Notice of References Cited Application/Control No. O9/513,040 Examiner Jacob Y Choi Applicant(s)/Patent Under Reexamination JIAO ET AL. Art Unit Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	Α	US-5735595	04-1998	Nederpel et al.	362/223
	В	US-5584572	12-1996	Ishikawa	362/346
	С	US-5055976	10-1991	Arai	362/17
	D	US-4218727	08-1980	Shemitz et al.	362/297
	Е	US-5195814	03-1993	Hasushita et al.	362/18
	F	US-5641218	06-1997	Sakurai	362/16
	G	US-5479328	12-1995	Lee et al.	362/216
	Н	US-			
	ı	US-			
i	J	US-			
	К	US-			
	L	US-			
	М	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	0					
	Р			_		,
	Q					
	R					
	S					
	Т					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)					
	U						
	٧						
	V						
	X						

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).) Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.